IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Haining S. YANG Group Art Unit: 2813

Appln. No.: 10/707,841 Examiner: Chen, Jack S.J.

Filed: January 16, 2004 Confirmation No.: 1840

For : METHOD AND STRUCTURE FOR CONTROLLING STRESS IN A

TRANSISTOR CHANNEL

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with Applicants' duty of disclosure under 37 C.F.R. §1.56, and pursuant to the provisions of 37 C.F.R. §§1.97 and 1.98, and supplemental to the Information Disclosure Statements filed on January 20, 2004, and August 23, 2005, Applicant hereby directs the Examiner's attention to the documents listed on the enclosed copy of the PTO-1449 Form.

Copies of the cited foreign patent documents and non-patent literature are being submitted herewith. However, pursuant to the U.S. Patent and Trademark Office's decision to waive the requirement under 37 C.F.R 1.98 (a)(2)(i), copies of the cited U.S. patents and U.S. published patent applications are not enclosed herewith. If any copies are needed, the Examiner is respectfully requested to contact the undersigned.

Applicant respectfully requests that the Examiner consider the materials cited and indicate such consideration by appropriately initialing the enclosed PTO-1449 Form and including a copy of the initialed form in the next official communication.

Applicant notes that while this Supplemental Information Disclosure Statement is being filed more than three months from the filing date, Applicant has not received a first action on the merits from the U.S. Patent and Trademark Office. Accordingly, consideration of the enclosed document is required under 37 C.F.R. 1.97(b)(3).

However, if the first action on the merit has been mailed prior to the filing date of this Supplemental Information Disclosure Statement, Applicant hereby authorizes the Commissioner to charge any fees necessary to ensure consideration of the documents cited herein to International Business Machines Deposit Account No. 09-0458.

Should there be any questions concerning this application, the Examiner is invited to contact the undersigned at the below listed telephone number.

Respectfully submitted, Haining S. YANG

Andrew M. Calderon Reg. No. 38,093

GREENBLUM & BERNSTEIN, P.L.C. 1950 Roland Clarke Place Reston, VA 20191 (703) 716-1191

.		artment of Commerce and Trademark Office		Atty. Dock P27160	cet No.	1	Application No. 10/707,841		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant Haining S. YANG					
			Filing Date January 16		Group 2813	· ·			
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449		•	U.S. Department of Commerce Patent and Trademark Office			Atty. Docket No. P27160			Application No. 10/707,841		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant Haining S. YANG						
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